Form PTO-1449 (REV. 8-83) U.S. Department of Commerce Patent and Trademark Office	ATTY. DOCKET NO. 879.1.018	SERIAL NO. 10/764,101
	APPLICANT(S) James A. Harrington, and Veena Gopal	
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	FILING DATE January 23, 2004	GROUP 2874

U.S. PATENT DOCUMENTS

Examiner Initial		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JD		5,815,627	9/29/1998	J. A. Harrington	385	125	
JD		5,567,471	10/22/1996	Harrington et al.	427	163.2	
JD		5,440,664	8/8/1995	J. A. Harrington	385	125	

Foreign Patent Documents

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES / NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

JD			Y. Fink, J. N. Winn, S. Fan, C. Chen, J. Michel, J. Joannopoulos, and E. Thomas, "A dielectric Omnidirectional Reflector," Science, Vol. 282, pp.1679-1682 (27 November 1998).
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Examiner	/Jennifer Doan/	DATE CONSIDERED	09/24/2006

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